



IFW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79595

Takeshi OONO, et al.

Appln. No.: 10/782,865

Group Art Unit: 2874

Confirmation No.: 7079

Examiner: Kevin S. Wood

Filed: February 23, 2004

For: SUBSTRATE ASSEMBLY FOR SUPPORTING OPTICAL COMPONENT AND
METHOD OF PRODUCING THE SAME

RESPONSE TO RESTRICTION AND ELECTION OF SPECIES REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Restriction Requirement of December 13, 2005, Applicant elects Group I, claims 1-6 (drawn to a substrate assembly for supporting an optical component) for prosecution, without traverse. Applicant reserves the right to request rejoinder of method claims including all the limitations of any allowable product claim pursuant to MPEP §821.04. Applicant also reserves the right to file a Divisional Application directed to the non-elected subject matter.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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Date: January 12, 2006